

INVENTOR INFORMATION

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CORRESPONDENCE INFORMATION

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APPLICATION INFORMATION

Title Line One:: BEAM HOMOGENIZER, LASER IRRADIATION APPA
Title Line Two:: RATUS, SEMICONDUCTOR DEVICE, AND METHOD
Title Line Three:: OF FABRICATING THE SEMICONDUCTOR DEVICE
Total Drawing Sheets:: 29
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: 740756-2256
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22204
Registration Number One:: 38285
Registration Number Two:: 35483
Registration Number Three:: 41345
Registration Number Four:: 45285
Registration Number Five:: 26477

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2000-024615
Filing Date:: 02-01-2000
Country:: Japan
Priority Claimed:: Yes

Source:: PrintEFS Version 1.0.1